

Erratum: “High performance InGaZnO thin-film transistors with high-k amorphous Ba_{0.5}Sr_{0.5}TiO₃ gate insulator”
[Appl. Phys. Lett. 93, 242111 (2008)]

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Citation: *Appl. Phys. Lett.* **94**, 119901 (2009); doi: 10.1063/1.3106227

View online: <http://dx.doi.org/10.1063/1.3106227>

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Erratum: “High performance InGaZnO thin-film transistors with high-*k* amorphous Ba_{0.5}Sr_{0.5}TiO₃ gate insulator” [Appl. Phys. Lett. 93, 242111 (2008)]

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(Received 4 March 2009; accepted 5 March 2009; published online 16 March 2009)

[DOI: [10.1063/1.3106227](https://doi.org/10.1063/1.3106227)]

We mistakenly reported on thin-film transistors having a subthreshold slope of 0.06 ± 0.01 V/decade. The corrected value for the average and standard deviation of the subthreshold slope in these transistors should read 0.11 ± 0.02 V/decade.

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